



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Jack O. Chu et al.

: Date: April 1, 2003

Serial No.: 09/989,770

: Group Art Unit: 2815

Confirmation No.: 2335

: Examiner: Jesse A. Fenty

Filed: November 20, 2001

: Attorney Docket No.: YOR919980460US

For: High Speed Composite p-Channel Si/SiGe Heterostructure for Field Effect Devices

Commissioner for Patents
Initial Patent Examination Division
Washington, D.C. 20231

49/2815
RECEIVED
APR 11 2003
TECHNOLOGY CENTER 2800

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

I hereby certify that the attached correspondence comprising:

1. Acknowledgment Post Card;
2. Petition and Fee for Extension of Time (37 CFR 1.136(a))
(in duplicate); and
3. Response to Restriction Requirement;

is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

**Commissioner for Patents
Initial Patent Examination Division
Washington, DC 20231**

on April 1, 2003

Barbara A. Miuccio
(Print name of person certifying)

Barbara A. Miuccio
(Signature of person certifying)